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Detailed simulation of inner tracker for the first physics run in the BM@N experiment

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BM@N experiment



BM@N tracking system

BM@N tracking system consists of high-precision coordinate detectors for charged particle track registration.

The tracking system is subdivided into three parts: **beam tracker**, **inner tracker** and **outer tracker**. The beam tracker includes detectors located inside the vacuum pipe to monitor and track the ion-beam. The inner tracker comprises detectors located inside the magnet, the outer – outside





Inner tracker

Inner tracker:

- **FSD (Forward Silicon Detector)** : 8 half-planes
- GEM (Gas Electron Multipliers) : 14 half-planes





Microstrip tracking detectors: particle registration



Scheme of particle track registration by planes of tracking detectors

- **1.** A heavy-ion beam, extracted from Nuclotron, collides with a fixed target.
- 2. As a result of this primary interaction is various particles. Their flying directions depend on their charge and a magnetic field which the detector located in (due to the Lorentz force).
- 3. Passing through the detector planes, a particle leaves a "trace" (response) on each of them. The main goal is to reconstruct a spatial coordinates, called "hit", which the particle passed through. A set of these hits on different planes from one particle defines its trajectory.



Tracking detectors in the BM@N setup (RUN-8) have two-coordinate microstrip readout. In order to reconstruct XY-coordinates the strips of one layer are rotated by certain angle with respect to another layer



Each readout layer consists of a set of strips. The response from a passing particle is represented by one or several fired strips (on each layer) that form a cluster (group of fired strips from one particle).

Forward Silicon Detector

Forward Silicon Detector (FSD) is a high-precision coordinate detector of the inner tracking system in the BM@N setup. It consists of a set of microstrip silicon modules which are assembled into 4 stations.





Silicon module types



6 modules of 63x93 mm² 10 modules of 63x126 mm²

Station 3: 14 modules of 63x126 mm²

Station 4: 14 modules of 63x126 mm²

Strip configuration in modules

Silicon stations



The configuration of strips in each module is represented by the corresponding schemes



Положение Si-сенсоров в полуплоскости # 7/1 (17.03.22)

озиция енсора	Х±0.02* (мм)	Y±0.02* (MM)	Разворот в плоскости ОХҮ (град.)**	Z±0.2*** (мм)	Серийный номер модуля	Позиция сенсора	Х±0.02* (мм)	Y±0.02* (MM)	Разворот в плоскости ОХҮ (град.)**	Z±0.2*** (мм)	Серийный номер модуля
Si-1a	65.59	164.17	0.05 пр. час.	27.7	#14	Si-5a	368.61	164.27	0.02 по час.	25.4	#30
Si-1b	65.48	101.15	0.05 пр. час.	27.6		Si-5b	368.53	101.27	0	25.9	
Si-2a	125.53	164.26	0.06 пр. час.	15.8	#36	Si-6a	428.63	164.26	0.02 по час.	14.2	#15
Si-2b	125.57	101.28	0.05 пр. час.	15.6		Si-6b	428.55	101.27	0.01 по час.	14.0	
Si-3a	185.55	164.18	0.07 пр. час.	27.6	#9	Si-7a	488.77	164.20	0.08 по час.	25.6	#29
Si-3b	185.57	101.18	0.06 пр. час.	27.5		Si-7b	488.63	101.21	0.08 по час.	26.0	
Si-4a	308.56	134.28	0.03 по час.	13.9	#22						
Si-4b	308.47	71.31	0.03 пр. час.	13.9	#55	 -положение точки начала координат SI-сенсора в координатной плоскости 0XY (привязана к наружным базовым отверстиям). 					

Silicon sensors have specific positions in each module of a station. They were measured with a high precision microscope to be taken into account in the model of the detector

GEM detector



Simulation stages for tracking detectors



Stages of data processing

- 1. Complete description of a detector:
 - a) Description of detector geometry (ROOT files)
 - b) Description of detector parameters (XML files)

2. Simulation:

- a) Monte-Carlo simulation
- b) Simulation of realistic effects

3. Procedures of getting "hits":

- a) Smearing Monte-Carlo points (hit producing)
- b) Hit reconstruction from "digits":
 - Realistic simulation + digitization
 - RAW experimental data + digitization



ROOT geometry for tracking detectors

What ROOT geometry is

*.ROOT – is a specific format developed for the ROOT data analysis framework which stores arrays of data and describes their structure, including the description of detector geometry.

Detector geometry describes physical dimensions of detector elements, their hierarchical structure and media that are need for Geant4 transport engine to propagate the charge particles through matter.

ROOT geometry of FSD detector

There are two versions of the ROOT geometry for MC-simulation: basic and detailed. The **basic geometry** consists of only sensor elements. The **detailed geometry** completely describes the detector including passive elements such as electronics, housing and supporting components.



Basic ROOT geometry of the FSD detector

elements of frames (aluminum**)**



Detailed ROOT geometry of the FSD detector

Adding passive elements to the geometry allows us to take into account detector materials which affect the passage of particles trough matter. This, in turn, improves the accuracy of the Monte-Carlo simulation.

ROOT geometry of GEM detector

The GEM detector has also two versions of geometry:

- **Basic ROOT geometry** comprises 14 sensitive volumes with simplified frames around each one.
- Detailed ROOT geometry completely describes the detector including passive elements such as electronics, housing and supporting components.





Detailed ROOT geometry of the GEM detector

Basic ROOT geometry of the GEM detector



Each active zone in a GEM chamber has a **multi-layer structure**. A layer has the following properties: thickness, material type and other characteristics which are taken into account in the Monte-Carlo simulation process.

Detailed simulation of GEM detector



Operation principle

Signal formation in a GEM chamber:

- 1. A particle passes through the detector and ionizes gas molecules, producing electron-ion pairs. Positive ions and electrons drift to the cathode and to the anode, respectively.
- 2. Primary electrons, passing through amplifying GEM cascades, gain their kinetic energy and enable secondary ionization. As a result of it is a lot of secondary electrons (electron avalanches). Amplification is about $10^4 10^5$.
- 3. Being collected on the anode, electrons form clusters on each strip layer.

Auxiliary tools for detailed simulation

Because the triple GEM detector has complex structure and complicated signal formation, **auxiliary tools** were used for detailed simulation of physics processes in gas chambers.

To take into account electromagnetic field in simulation we used **GMSH** and **ELMER** tools for calculation of required fields:



Example of calculated field for one GEM cell: equipotential and electric field lines (GEM hole, GEM1 = 0.6 cm)

We used **Garfield++** for detailed simulation of physics processes in our GEM chamber:

Physics processes steps:

- 1. Gas ionization by a charged particle.
- 2. Electron drift to an anode readout (under electric and magnetic fields)
- Electron avalanches production (as result of multiplication in GEM holes)
- 4. Electron shift (under the Lorentz force influence in mag. field)



Electron avalanche production in our triple GEM

Detailed simulation procedure in BMINROOT

Based on obtained distributions and dependencies (from auxiliary tools) required for realistic simulation, the algorithm was developed to simulate the digits (signals on strips)





Example of distribution of produced electrons that form a signal

Detailed simulation steps:

The characteristics obtained from Garfield++ allow us to build a data acquisition model according to the following scheme:



- 1. Based on the information extracted from the MC-point obtained by using the Geant4 simulation, we have parameters such as: coordinates of the particle entry into the GEM chamber; momentum of the particle, its type and direction
- We determine the track of the particle in the volume of chamber (a line from the entry point of the particle to its exit)
- Based on the ionization characteristics obtained in Garfield++, we determine positions of primary interaction clusters
- Based on the distributions of the mean shift and diffusion of electrons, we genrate the distribution of electron avalanches on the readout plane (on the strips)

5. Result: clusters on the strips

Detailed simulation of FSD detector

Operation principle



Signal formation in a silicon module:

- A particle, passing through the detector medium, produces electron-hole pairs by impact ionization.
- 2. Then mobile carriers (electrons and holes) drift to the electrodes, generating a current signal on the readout planes.

Clusters on the silicon strip readout

Example: A set of clusters of the strip layer in one module of the FSD detector on experimental data (RUN-8: Xe beam with CsI target)



Detailed simulation procedure in BMNROOT

The signal formation on strips in a silicon detector doesn't has amplification effects (in comparison with a triple GEM chamber). The main signal is formed due to charged carriers (electron and holes) produced as a result of primary impact ionization.

Steps of the detailed simulation algorithm:



Data simulation for RUN-8



Data simulation and reconstruction for RUN-8





Microstrip tracking detectors: software implementation



Summary

What has been reviewed:

- Software for detailed simulation of inner tracking detectors (BM@N RUN-8 configuration):
 - o Forward Silicon Detector
 - o GEM detector

Thank you for your attention...